

03500.015730.



PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: )  
TAKASHI IWAKI ET AL. )  
Appln. No.: 09/941,782 )  
Filed: August 30, 2001 )  
For: ELECTRON-EMITTING )  
DEVICE, ELECTRON SOURCE )  
AND METHOD FOR )  
MANUFACTURING IMAGE- )  
FORMING APPARATUS ) July 10, 2003

Mail Stop DD  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

INFORMATION DISCLOSURE STATEMENT

Sir:

In compliance with the duty of disclosure under 37 C.F.R. § 1.56 and in accordance with the practice under 37 C.F.R. §§ 1.97 and 1.98, the Examiner's attention is directed to the documents listed on the enclosed Form PTO-1449. Copies of the listed documents are also enclosed.

The Examiner's attention is also directed to the following U.S. application:

<u>APPLICATION NO.</u>	<u>FILING DATE</u>	<u>GROUP ART UNIT</u>
10/370,662	2/24/03	1762

A copy of the cited application is enclosed.

CONCLUSION

It is respectfully requested that the above information be considered by the Examiner and that a copy of the enclosed Form PTO-1449 be returned indicating that such information has been considered.

We also enclose a check for the required fee of \$180.00 to cover the Information Disclosure Statement under 37 C.F.R. 1.97(c)(2).

Applicants' undersigned attorney may be reached in our New York office by telephone at (212) 218-2100. All correspondence should continue to be directed to our address given below.

Respectfully submitted,



\_\_\_\_\_  
Attorney for Applicants  
Frank A. DeLucia  
Registration No. 42,476

FITZPATRICK, CELLA, HARPER & SCINTO  
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FORM PTO 1449 (modified)

U.S. DEPARTMENT OF COMMERCE  
PATENT AND TRADEMARK OFFICELIST OF REFERENCES CITED BY APPLICANT(S)  
(Use several sheets if necessary)ATTY DOCKET NO.  
**03500.015730**

APPLICATION NO.

**09/941,782**

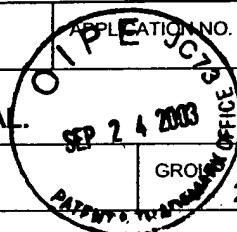
APPLICANT

**TAKASHI IWAKI ET AL.**

FILING DATE

**AUGUST 30, 2001**

OCT 24 2003

GPO  
2875

## U.S. PATENT DOCUMENTS

*EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
		2002/0117670	8/2002	Horiguchi et al.	257	59	

## FOREIGN PATENT DOCUMENTS

		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION YES/NO/ OR ABSTRACT
	EP	1 184 886 A1	3/2002	EPO	H01J	9/02	
	JP	11-120901	4/1999	Japan	H01J	9/02	Abstract

## OTHER DOCUMENT(S) (Including Author, Title, Date, Pertinent Pages, Etc.)

		Akiyoshi Baba et al., "Field Emission from an Ion-Beam-Modified Polyimide Film," Japanese Journal of Applied Physics, Publication Board Japanese Journal of Applied Physics, Tokyo, JP, Vol. 38 (1999), NR. 3A pp. L261-L263.

EXAMINER

DATE CONSIDERED

\*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

Sheet 1 of 1

03500.015730

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: )  
TAKASHI IWAKI ET AL. )  
Application No.: 09/941,782 )  
Filed: August 30, 2001 )  
For: ELECTRON-EMITTING DEVICE, )  
ELECTRON SOURCE AND )  
METHOD FOR MANUFACTURING )  
IMAGE-FORMING APPARATUS : September 23, 2003  
Examiner: P. Macchiarolo  
Group Art Unit: 2875  
Confirmation No.: 7656

Mail Stop Issue Fee  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

REQUEST FOR CONSIDERATION OF PREVIOUSLY CITED ART

Sir:

Applicants have received a Notice of Allowance in the above-identified application. The Examiner is sincerely thanked for allowing the application. However, Applicants have not yet received confirmation that the Information Disclosure Statement filed on July 11, 2003 has been considered in this application. A copy of the Information Disclosure Statement and a copy of the accompanying Form PTO-1449 are enclosed, as is a copy of the return receipt postcard stamped to confirm receipt of those papers by the Patent and Trademark Office.

Applicants respectfully request that the Examiner consider and make of record the art cited in the mentioned Information Disclosure Statement, and issue an initialed copy of the Form PTO-1449 as confirmation thereof.

If the Examiner requires additional copies of the art cited in the Information Disclosure Statement, he is respectfully requested to telephone the undersigned.

Applicants' undersigned attorney may be reached in our New York office by telephone at (212) 218-2100. All correspondence should continue to be directed to our below listed address.

Respectfully submitted,

  
\_\_\_\_\_  
Attorney for Applicants  
\_\_\_\_\_  
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Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Date 7 / 11 / 03  
Mo. Day Yr.

Atty. Docket 3500.015730  
Application No. 09/941,782

Sir:

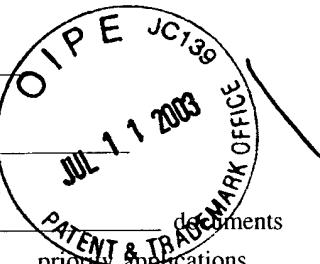
Kindly acknowledge receipt of the accompanying:

- Response to Official Action.  
 Check for \$ 180.00 (claim fee)  
 Petition under 37 CFR 1.136 and Check for \$ \_\_\_\_\_  
 Notice of Appeal and Check for \$ \_\_\_\_\_  
 Information Disclosure Statement, PTO-1449 and 5 documents  
 Claim for priority and certified copies of \_\_\_\_\_ priority applications  
 Issue fee transmittal and Check for \$ \_\_\_\_\_  
 Other (specify) \_\_\_\_\_

by placing your receiving date stamp hereon and returning to deliverer.

Atty. FAD/VT/bcg

Due Date N / D / D  
Mo. Day Yr.



*By Hand*